



CMDITR 101: Project 4.2

Packaging and Processing For Printed Electronics

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Example: Flexible Electronics



The Functionality, Reliability and Processing of Organic Electronic Devices Are Linked To Packaging and Processing Methods

What is Important In Designing and Evaluating Packaging???

Center on Materials and Devices for Information Technology Research - An NSF Science and Technology Center No. DMR 0120967

Annual Retreat - February 16-20, 2010 - Seattle, WA

<http://www.stc-mditr.org>



Reliability Issues: Device Encapsulation

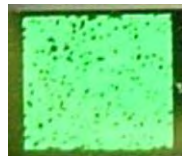
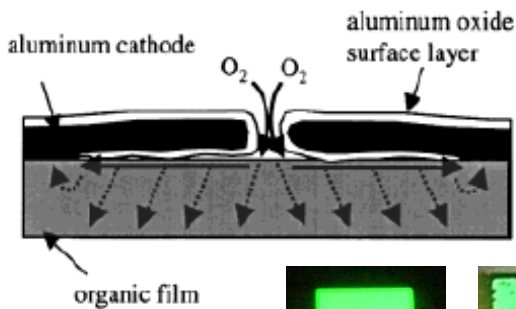


Need for Barrier Layers

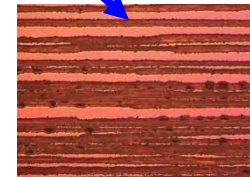
- Highly reactive cathode and organic layer are very sensitive to water vapor and oxygen.
- Organic materials are sensitive to high temperatures and oxidizing agents.

Must address:

- ⇒ **Development of high barrier performance films.**
- ⇒ **Process compatibility with device.**
- ⇒ **Extending technology to large areas and devices with topography.**



1 min



1 hr

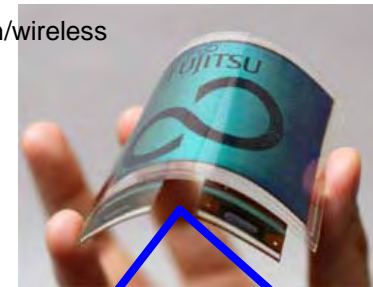
Mechanical Concerns

- Inorganic layers found in encapsulation are generally very brittle and may crack during bending.
- Internal stresses from processing can impact the reliability of the encapsulation.

Must address:

- ⇒ **Mechanically robust barrier layers.**
- ⇒ **Adhesion and stress management.**

<http://wirelessmedia.ign.com/wireless/image/article>

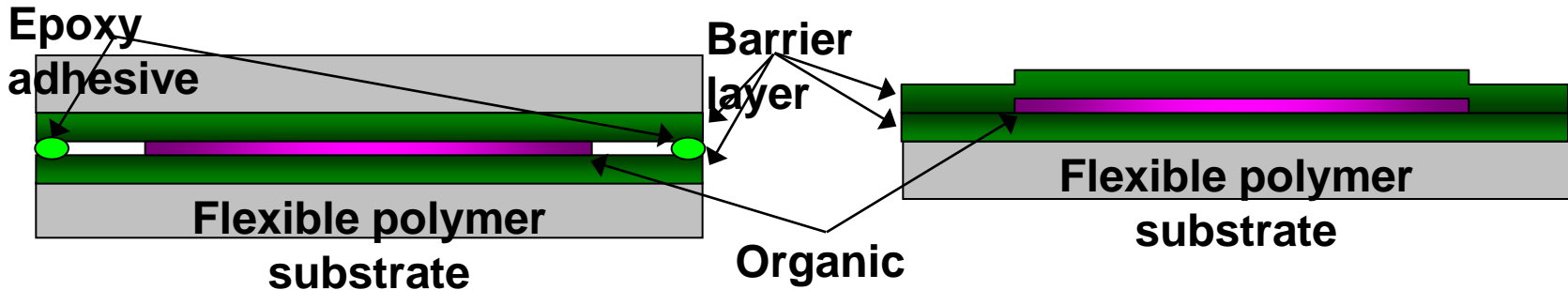
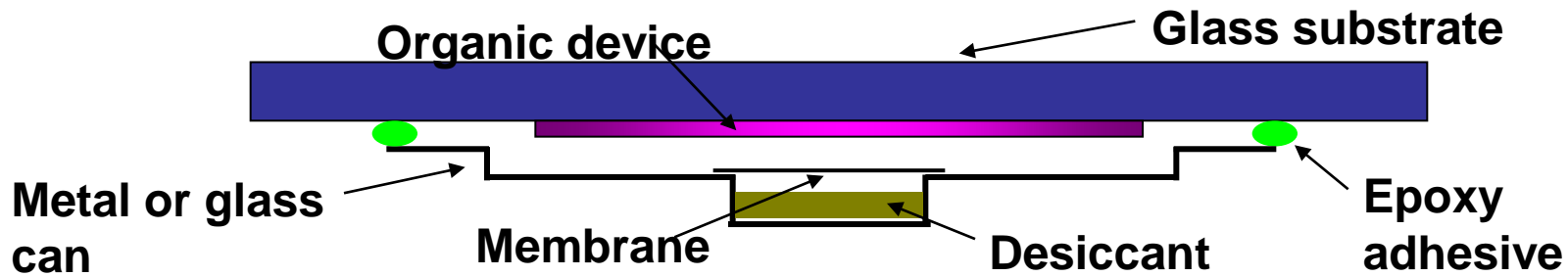




Encapsulation Structures



heavy, thick, rigid,
side permeation through epoxy



+ : flexible, light

- : need to fabricate barrier layer on both substrates, side permeation

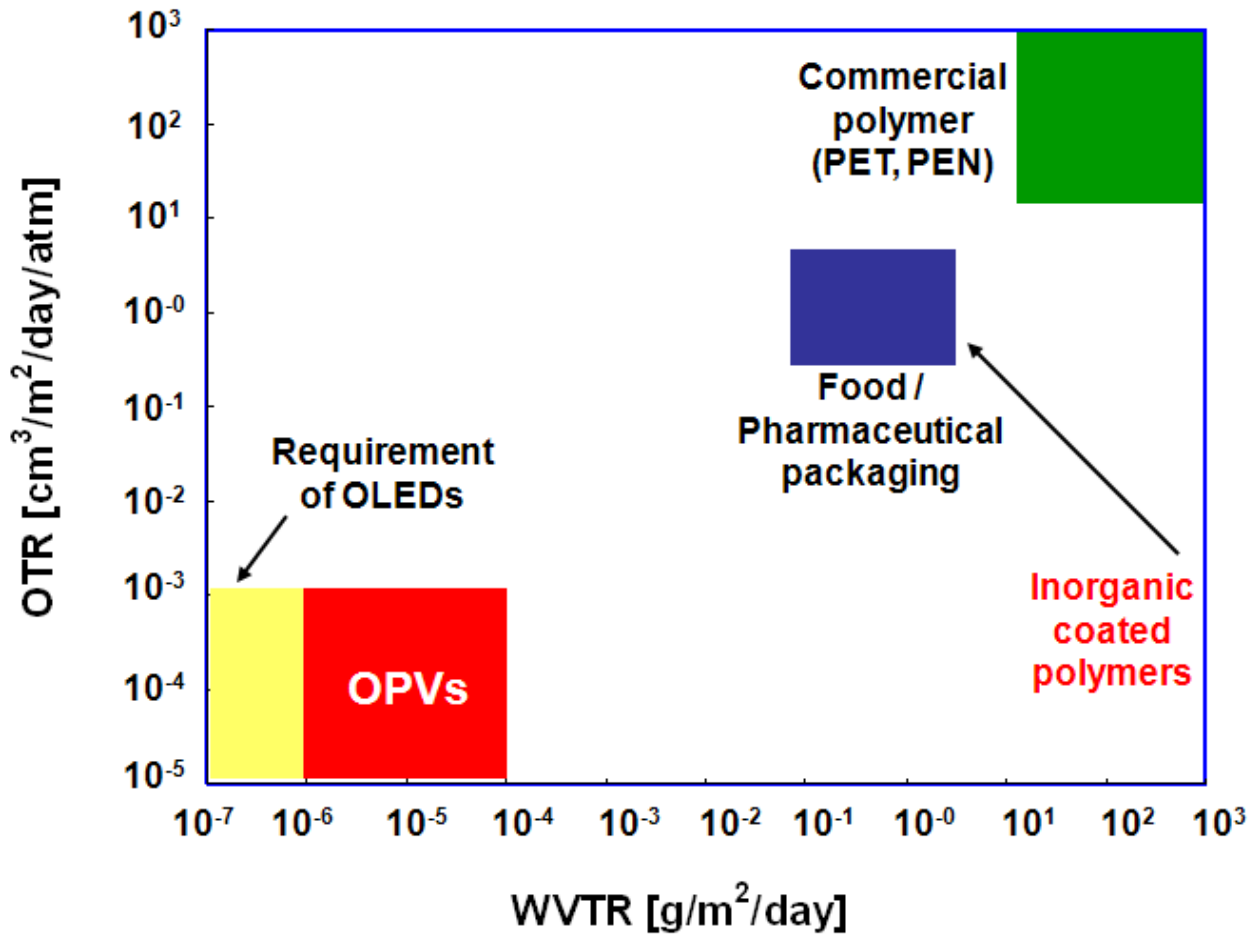
Organic device

+ : thin, very flexible, light, no side permeation

- : need to fabricate barrier layer on device



Encapsulation Performance Needs



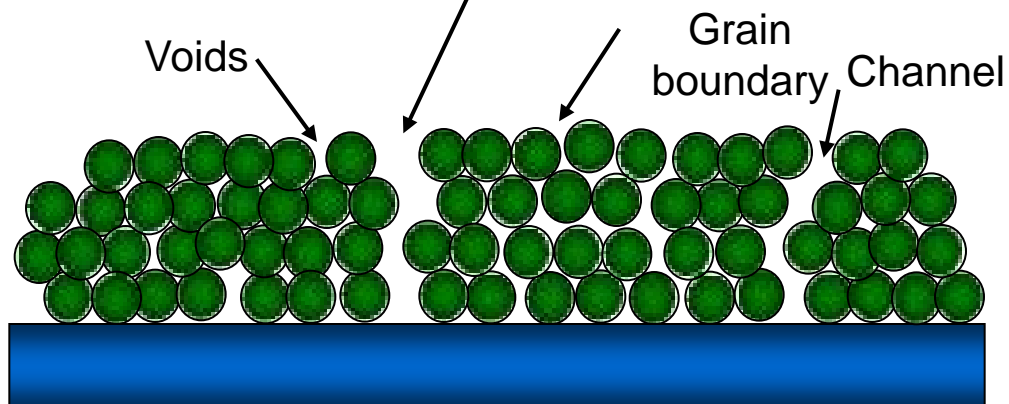
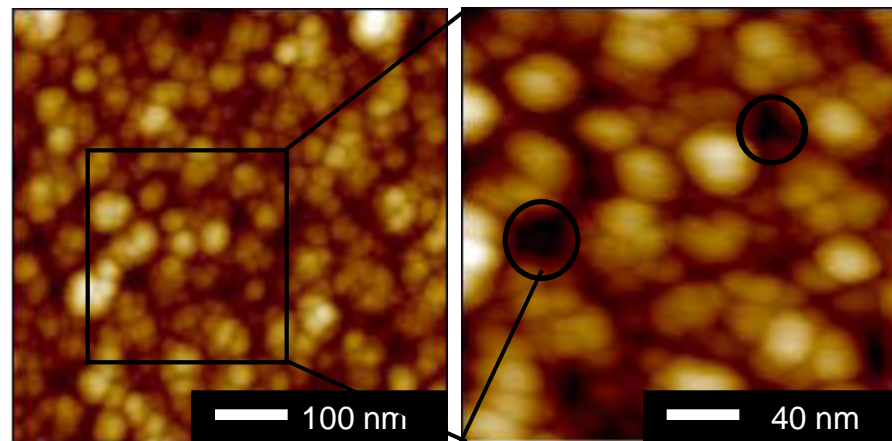
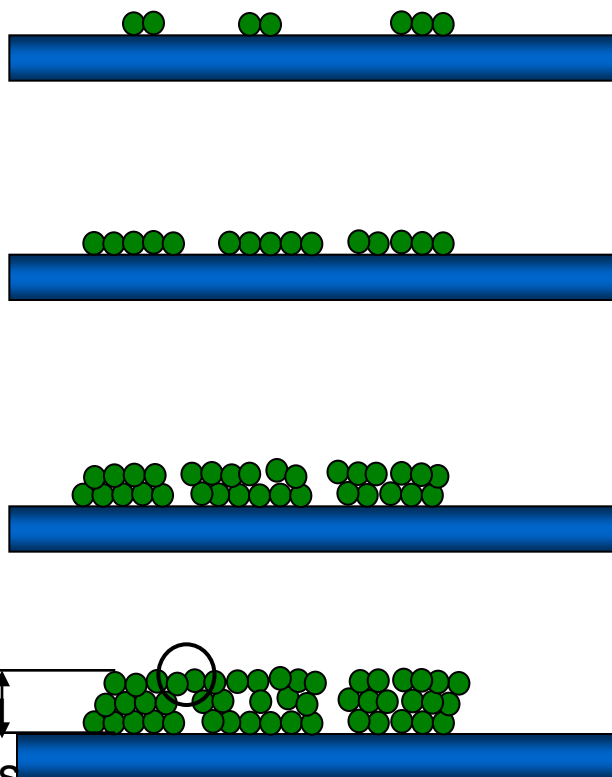
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Defects in Barrier Films



Single Layer Thin Films





Key Terminology



- **Water Vapor Transmission Rate**

- The mass of water vapor which diffuses through a solid per unit area and unit time (g/m²/day)

- **Permeability**

- transmission rate x film thickness/pressure

- **Bending Strength**

- The load at which a material undergoes nonlinear deformation (yield) or undergoes failure (failure strength)

- **Fatigue Strength**

- The strength amplitude at which failure does not occur in materials under cyclic loading. Usually defined for a given number of cycles (e.g. 10⁶)

- **Toughness**

- The amount of energy a material can absorb before failure.



Mass Transport in Barrier Films



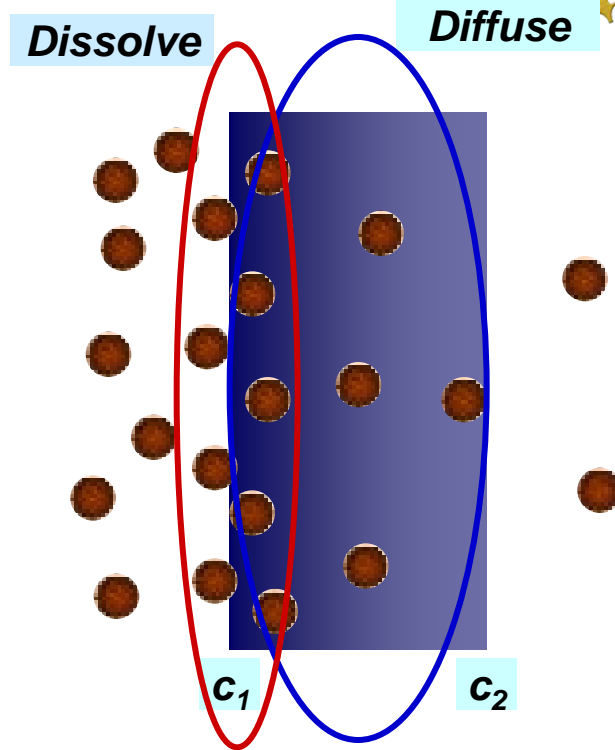
Principles of permeation

$$P = DS$$

P : Permeation coefficient (permeability)

D : Diffusion coefficient, determines how **fast** the permeant can **move** in the media

S : Solubility coefficient, determines how **much** of the permeant can **be dissolved in in the film**



Driving force

$$J = -D \left(\frac{\partial c}{\partial x} \right)$$

Fick's first Law

$$\rightarrow c = Sp$$

Henry's Law

$$J = DS \frac{\Delta p}{l}$$

J : Flux of permeant

$\partial c / \partial x$: concentration gradient

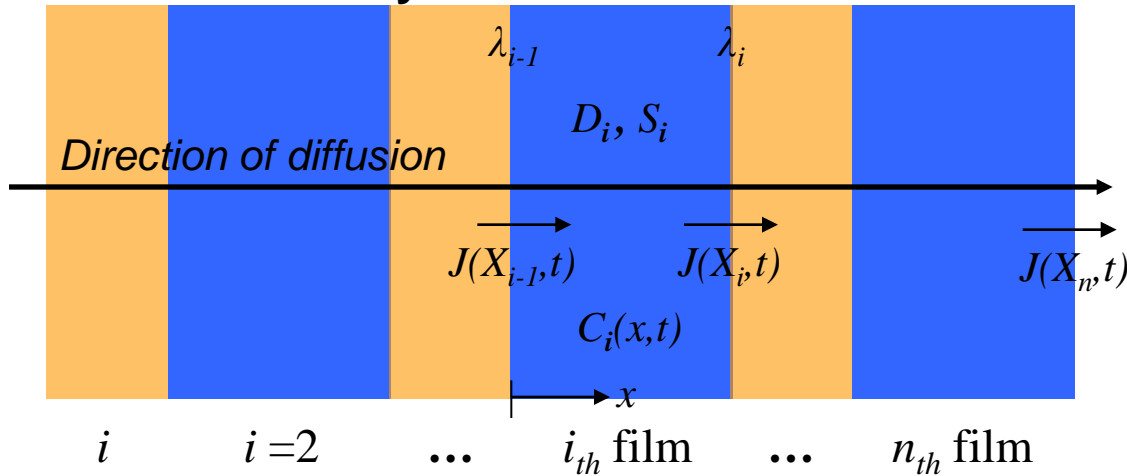
p : Partial pressure of permeant



Mass Transport in Barrier Films

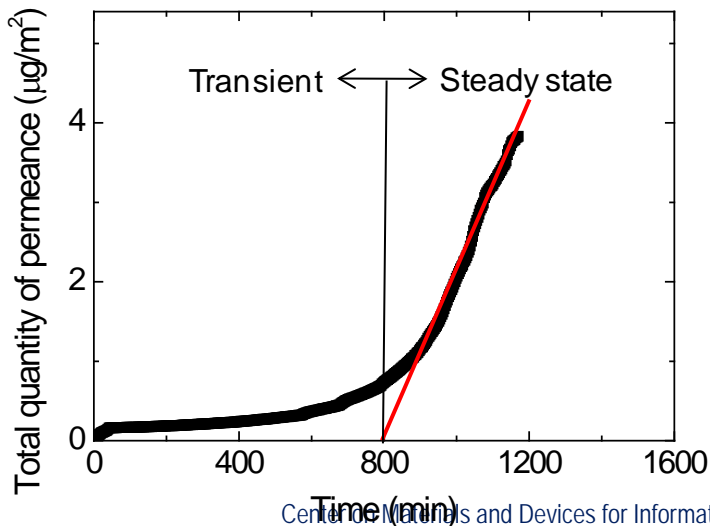


Diffusion in multilayer structure



D_i (diffusivity),
 S_i (Solubility),
 L_i (thickness)-fixed
 Defect spacing

WVTR, Lag time



Lag Time: 1300 hours

Transient WVTR: 8×10^{-6} g/m²/day

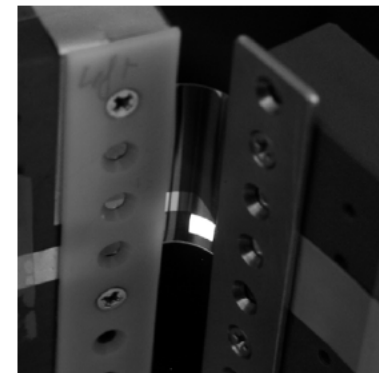
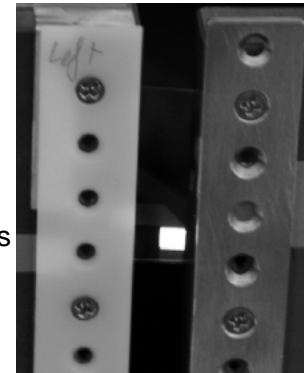
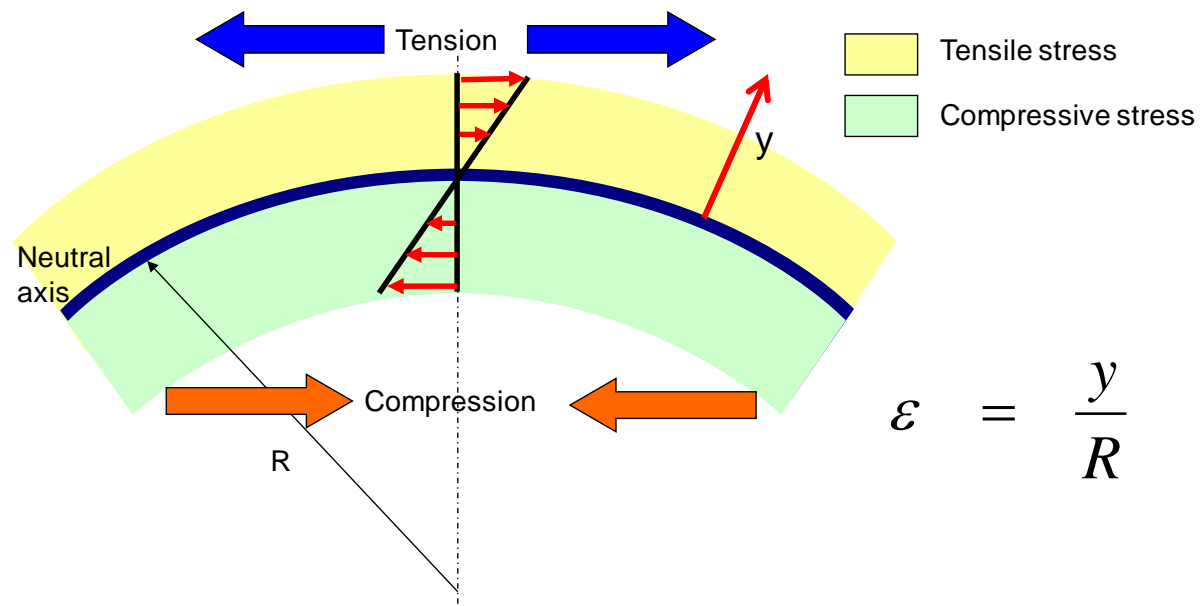
Steady State: 2×10^{-3} g/m²/day



Bending of Flexible Electronics



Flexural deformation puts one surface in tension, one in compression. Brittle Materials used in encapsulation fail easily under tension, not compression. The strain or stress induced in the films are a function of bending radius AND substrate thickness. Under 2 point bending, the strain is highest in the center, lower at the edges. Repeated bending results in the initiation of damage and failure.

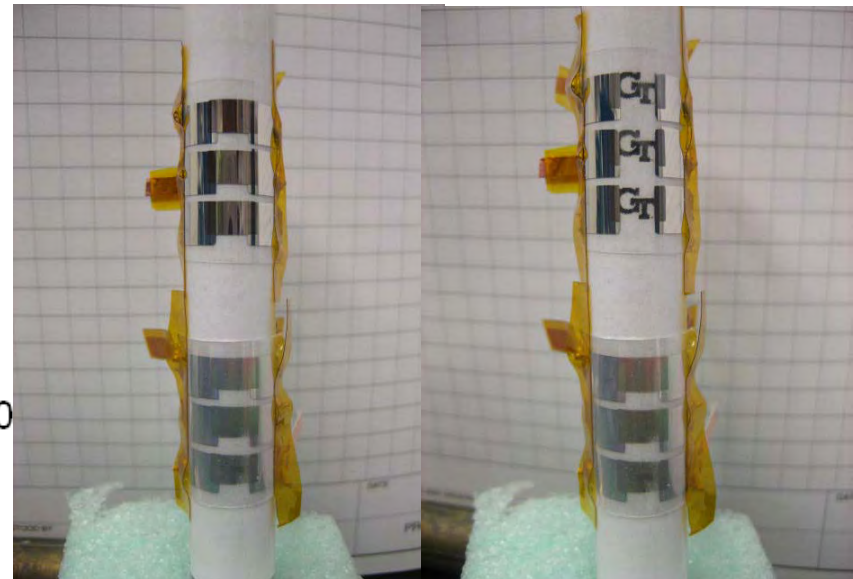
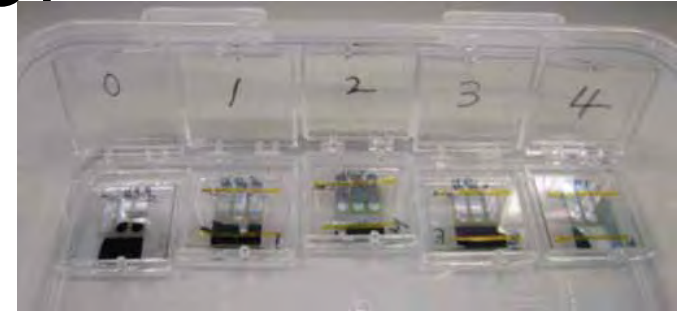
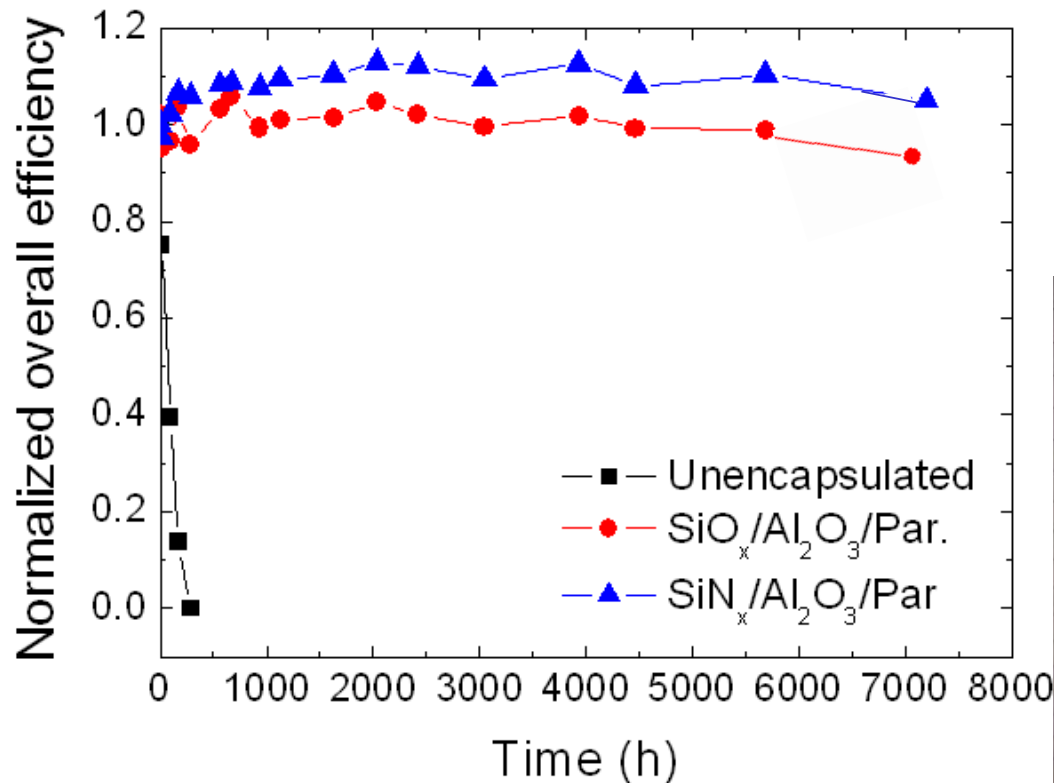




Lifetime and Reliability



Overall device efficiency (Oriel 91160, AM 1.5G)





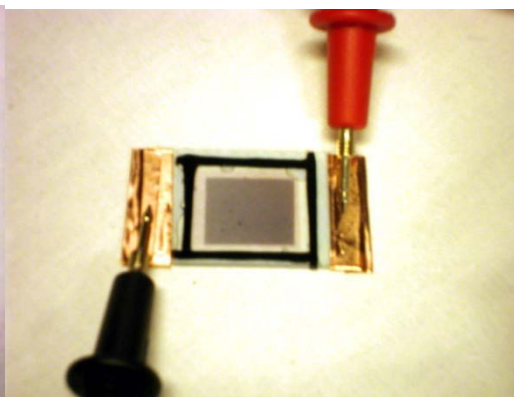
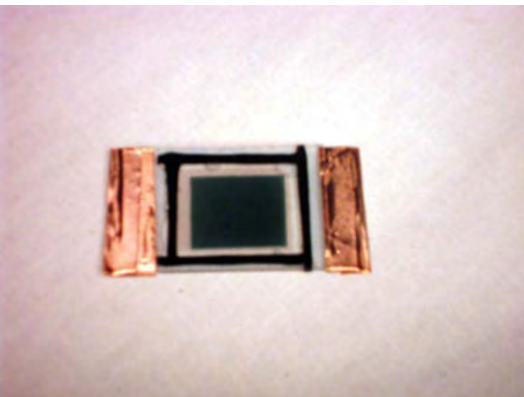
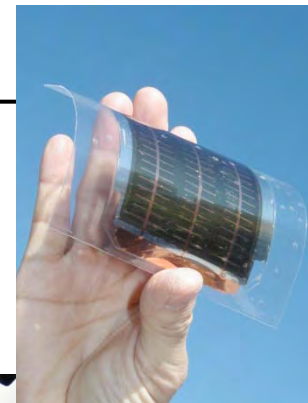
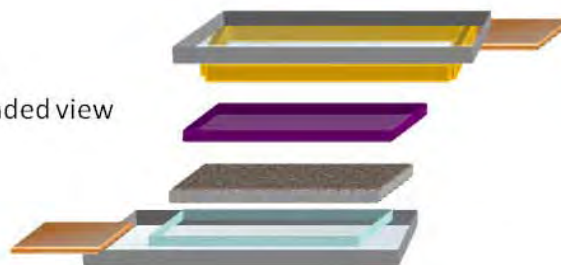
Sealing Materials



**New Sealant Material used to encapsulate electrochromics.
Shows WVTR values as low as 5×10^{-5} g/m²/day at 50C/80% RH.
Ca samples tested for 3 months.**



Side-expanded view

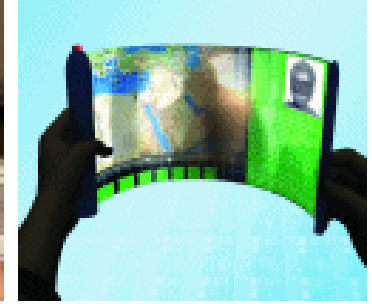




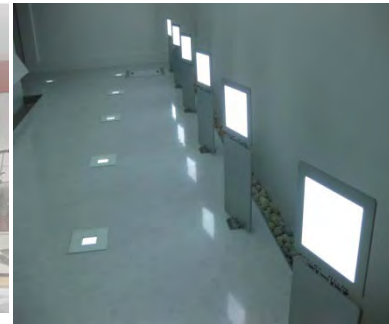
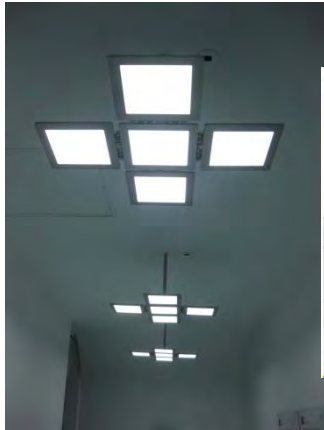
Societal Impact/ Applications



Displays



Solid State Lighting



Solar Cells



Flexible Transistors

